



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: Confirmation No. 3771

Yoichiro NUMASAWA et al.

: Docket No. 2003_1106A

Serial No. 10/642,619

: Group Art Unit 1754

Filed August 19, 2003

: Examiner Ngoc Yen M. Nguyen

APPARATUS AND METHOD FOR
MANUFACTURING HALOGEN GAS AND
HALOGEN GAS RECOVERY AND
CIRCULATORY SYSTEM

:

:

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a two month extension of time to respond to the communication of March 24, 2005.

The fee of \$450.00 is

submitted herewith.
 to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

 Small entity status of this application is established by a Small Entity Status Assertion which
 is enclosed.
 has been previously submitted.

Respectfully submitted,

Yoichiro NUMASAWA et al.

By

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June 23, 2005

06/24/2005 HAL111 00000106 10642619

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